

UNITED STATES PATENT AND TRADEMARK OFFICE

BEFORE THE PATENT TRIAL AND APPEAL BOARD

MICRON TECHNOLOGY, INC.

Petitioner

v.

PRESIDENT AND FELLOWS OF HARVARD COLLEGE

Patent Owner

PTAB Case No. To Be Assigned

U.S. Patent No. 8,334,016

POWER OF ATTORNEY

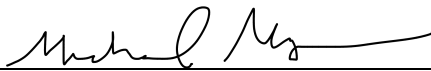
Pursuant to 37 C.F.R. 42.10(b), Petitioner Micron Technology, Inc. hereby appoint the following lead and back-up counsel to transact all business before the Patent Trial & Appeal Board of the United States Patent and Trademark Office in connection with a Petition for *Inter Partes* Review of U.S. Patent No. 8,334,016 entitled “VAPOR DEPOSITION OF METAL OXIDES, SILICATES AND PHOSPHATES, AND SILICON DIOXIDE.”

Petition for *Inter Partes* Review of Patent No. 8,334,016

Lead Counsel	Back-Up Counsel
Jeremy Jason Lang Reg. No. 73,604 WEIL, GOTSHAL & MANGES LLP 201 Redwood Shores Parkway Redwood Shores, CA 94065 650-802-3237 (phone) 650-802-3100 (fax) <i>Attorney for Micron Technology, Inc.</i>	Jared Bobrow <i>Pro hac vice</i> to be submitted WEIL, GOTSHAL & MANGES LLP 201 Redwood Shores Parkway Redwood Shores, CA 94065 650-802-3034 (phone) 650-802-3100 (fax) <i>Attorney for Micron Technology, Inc.</i>

The undersigned is authorized to sign this Power of Attorney on behalf of
Petitioner Micron Technology, Inc.

Date: 1/9/2017



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Micron Technology, Inc.